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Bib Data Sheet

**CONFIRMATION NO. 6766** 

SERIAL NUMB 09/912,982			(	CLASS 438	GROUP ART UNIT 2812			ATTORNEY DOCKET NO. 4375US (99-1029)	
** CONTINUING ** FOREIGN APF ** TOREIGN APF	DATA W PLICA	n, Cedar Park, TX;  A ***********************************		ED .	<u> </u>				
Foreign Priority claimed yes no  35 USC 119 (a-d) conditions yes no Met after met  Verified and Acknowledged Examiner's Signature Initials				STATE OR COUNTRY	SHEETS DRAWING 10		TOTAL CLAIMS 94		INDEPENDENT CLAIMS 7
ADDRESS 24247 TITLE									
Differential pressure application apparatus for use in polishing layers of semiconductor device structures and methods									
RECEIVED	No	ES: Authority has been given in Paperto charge/credit DEPOSIT ACCOUNTfor following:				☐ All Fees ☐ 1.16 Fees ( Filing ) ☐ 1.17 Fees ( Processing Ext. of time ) ☐ 1.18 Fees ( Issue ) ☐ Other ☐ Credit			